Transaction Information

Tool Status	Running Wafers
Location	
Wafer Size	200 mm
Fab Section	Clean
Tool Available Date	

General Product Information

Vendor Supplier	FSI
Model	
Vintage	2015
Asset Description	FSICL MECURRY PROCESS
Software Version	586
CIM	SECS,GEM
Process	Batch process

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Handler System	NA		
Options System			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
NONE		

Missing/Faulty Parts / Accesorries List

Description	Quantity
NONE	

General: Main tool, Booster Pump,Diw heater, Canister Console, UPS,Transformer,Parts